



Serial No. 10/712,100  
SKI.008C2  
Amendment dated October 12, 2005

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of

Shunji Hayashi

Group Art Unit: 2125

Serial No.: 10/712,100

Examiner: K. Bahta

Filed: November 14, 2003

Confirm No.: 8230

For: METHOD AND SYSTEM FOR MANAGING SEMICONDUCTOR  
MANUFACTURING EQUIPMENT

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**AMENDMENT**

U.S. Patent and Trademark Office  
Customer Window, **Mail Stop Amendment**  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Date: October 12, 2005

Sir:

In response to the Office Action dated May 12, 2005, the period for response having been extended two (2) months to October 12, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.